

IN THE UNITED STATES PATENT AND TRADEMARK OFFICEApplicant(s): **Branco et al.**Serial No.: **09/617,454**Filed: **July 17, 2000**Title: **Method for Cleaning Plasma Etch
Chamber Structures**Attorney Docket No.: **CY-0015**Group Art Unit: **1746**Examiner: **Markoff, A.**RECEIVED
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RESPONSE TO OFFICE ACTION

- 5 Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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A. Introductory Comments

The following is submitted in response to the Notice of Non-Compliant Amendment
dated April 1, 2004, and is currently due May 1, 2004.

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37 C.F.R. §1.8

I hereby certify that this correspondence is being

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☒ transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9306Date of Transmittal: APRIL 6, 2004☐ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450.

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Date of Deposit: APRIL 6, 2004Typed/Printed Name: Bradley T. Sako

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Signature: [Signature]